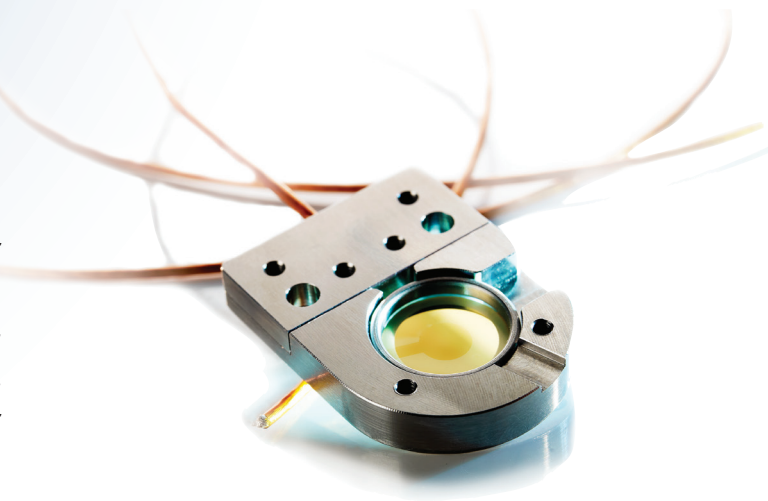


# Q-Sense ALD Holder 401

● The Q-Sense ALD (Atomic Layer deposition) Holder is designed to enable QCM-D measurements in vacuum or gas phase.

The Holder is open on both sides of the sensor to prevent uneven pressure changes over the two sensor faces, hence enabling measurements in both low and high ambient pressures. Cables are provided to connect the ALD Holder to the measurement chamber. Via two separate cables, the measurement signal is transferred through the chamber wall to the QCM-D electronics unit.



## ● SPECIFICATIONS: QVH 401

Sensors	Compatible with all Q-Sense 14 mm sensors
Type of measurements	Gas measurements in vacuum and high pressure chambers
Materials exposed to gas	Stainless steel, macor, aluminum, kapton
Maximum temperature	250 °C
Dimensions	Height: 5 mm; Width: 24 mm; Depth: 32 mm
Other	Customer installation / adaption required

*Specifications subject to change without notice*

